

10/529525

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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of:

Yasuhide Onozawa

International Application No. PCT/JP03/12656

International Filing Date: October 2, 2003

For: SURFACE MOUNT SAW DEVICE
MANUFACTURING METHOD

Art Unit: ---

Examiner: ---

TRANSMITTAL OF INFORMATION DISCLOSURE STATEMENT
UNDER 37 CFR 1.97(b)

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Dear Sir:

Pursuant to 37 CFR 1.56, 1.97(b) and 1.98, Applicant for the above-identified application hereby submits legible copies of the following relevant art along with the Form PTO-1449 which contains the information required by 37 CFR 1.98(b):

- A. Japanese Patent Application Laid-Open (Kokai) No. 2001-332654 A published by the Japanese Patent Office on November 30, 2001;
- B. Japanese Patent Application Laid-Open (Kokai) No. 07-176565 A published by the Japanese Patent Office on July 14, 1995;
- C. Japanese Patent Application Laid-Open (Kokai) No. 2002-232260 A published by the Japanese Patent Office on August 16, 2002;
- D. Japanese Patent Application Laid-Open (Kokai) No. 2002-198403 A published by the Japanese Patent Office on July 12, 2002;

- E. Japanese Patent Application Laid-Open (Kokai) No. 2000-091381 A published by the Japanese Patent Office on March 31, 2000;
- F. Japanese Patent Application Laid-Open (Kokai) No. 05-55303 A published by the Japanese Patent Office on March 5, 1993;
- G. Japanese Patent Application Laid-Open (Kokai) No. 2003-283295 A published by the Japanese Patent Office on October 3, 2003;
- H. PCT Application Japanese National Publication No. 2002-504773 A published by the Japanese Patent Office on February 12, 2002; and
- I. PCT Application Japanese Secondary National Publication No. WO 97/2596 published by the Japanese Patent Office on January 23, 1997.

The prior arts A through I are all cited in the International Search Report issued on January 20, 2004 to the PCT/JP03/12656 upon which the above-identified U.S. application is filed. A copy of the Search Report is enclosed.

The above-listed prior arts are not in the English language, but the Search Report is written in English and the degree of relevance is indicated therein by way of the markings of A's, Y's and P's along with the explanation of such markings. Accordingly, pursuant to MPEP Section 609, the requirement for a concise explanation of relevance for the non-English language prior art is satisfied and an English concise explanation thereof is omitted herein. Nonetheless, an English summary of these non-English language prior arts is attached to copies of these prior arts.

It is, therefore, respectfully requested that the Patent Office make a record of these relevant arts and consider them during the prosecution.

Respectfully submitted,

Date: March 29, 2005

By: _____

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FORM PTO-1449			Docket Number (Optional) 172A 3682 PCT		Application Number 10/529525	
INFORMATION DISCLOSURE CITATION IN AN APPLICATION			Applicant Yasuhide Onozawa			
<i>(Use several sheets if necessary)</i>			Filing Date --		Group Art Unit --	
U.S. PATENT DOCUMENTS						
EXAMINER INITIAL	DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE
FOREIGN PATENT DOCUMENTS						
	DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	TRANSLATION (YES/NO)
	JP 2001-332654 A	11/30/2001	Japan	H01L	23/12	No
	JP 07-176565 A	7/14/1995	Japan	H01L	21/60	No
	JP 2002-232260 A	8/16/2002	Japan	H03H	9/25	No
	JP 2002-198403 A	7/12/2002	Japan	H01L	21/60	No
	JP 2000-091381 A	3/31/2000	Japan	H01L	21/60	No
	JP 05-055303 A	3/5/1993	Japan	H01L	21/60	No
	JP 2003-28295 A	10/3/2003	Japan	H03H	9/25	No
	JP 2002-504773 A	2/12/2002	Japan	H03H	3/02	No
	WO 97/02596	1/23/1997	Japan	H01L	21/56	No
OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.)						
EXAMINER		DATE CONSIDERED				
EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP § 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to the applicant.						